

RECEIVED  
CENTRAL FAX CENTER

DOCKET NO. SC0192WD

NOV 24 2004

## FAX TRANSMITTAL SHEET

Freescale Semiconductor, Inc.  
Law Department  
7700 W. Parmer Lane  
MD: TX32/PL02  
Austin, TX 78729  
Telephone: (512) 996-6839  
Facsimile: (512) 996-6854

8

Number of Pages (including this page)

Date: November 24, 2004  
To: Zoila E. Cabrera - 2125  
Location: United States Patent and Trademark Office  
Fax No.: (703) 872-9306  
From: Joanna G. Chiu - 43,629  
Subject: 09/729,636- Karl E. Mautz et al.

NOTICE: This facsimile transmission may contain information that is confidential, privileged, or exempt from disclosure under applicable law. It is intended only for the person to whom it is addressed. Unauthorized use, disclosure, copying or distribution may expose you to legal liability. If you have received this transmission in error, please immediately notify us by telephone (collect) to arrange for return of the documents received and any copies made. Thank you.

## MESSAGE:

Enclosed herewith, please find a FORMAL RESPONSE TO REJECTION for filing in the below-identified application. If Applicant has overlooked any fees, or if any overpayment has been made, the Commissioner is hereby authorized to credit or debit Deposit 503079, Freescale Semiconductor, Inc.

## ALL ITEMS MARKED WITH AN "X" ARE INCLUDED:

|    |   |                              |
|----|---|------------------------------|
| 1. | x | 1 page Facsimile Cover Sheet |
| 2. | x | 7 page Response to Rejection |

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS  
BEING FACSIMILE TRANSMITTED TO THE PATENT AND TRADEMARK OFFICE:

ON: 11/24/04  
Date

Elaine Cox  
Signature

PLEASE GIVE THESE PAPERS TO:

EXAMINER: Zoila E. Cabrera  
GROUP ART UNIT: 2125  
SERIAL NO.: 09/729,636  
FILED: DECEMBER 4, 2000  
INVENTOR: KARL E. MAUTZ ET AL.

DOCKET NO. SC0192WD

UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S) Karl E. Mautz et al. GROUP ART UNIT: 2125  
APPLN. NO.: 09/729,636 EXAMINER: Zoila E. Cabrera  
FILED: December 4, 2000  
TITLE: ASSEMBLY COMPRISING A PLURALITY OF MASK CONTAINERS,  
MANUFACTURING SYSTEM FOR MANUFACTURING  
SEMICONDUCTOR DEVICES, AND METHOD

RECEIVED  
CENTRAL FAX CENTER  
NOV 24 2004

Certificate of Transmission under 37 CFR 1.8

I hereby certify that this correspondence is being facsimile  
transmitted to the Patent and Trademark Office.

on

11/24/04

*Elaine Cox*  
Signature

Pat Thomas  
Printed Name of Person Signing Certificate

RESPONSE TO REJECTION

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated January 29, 2004, and Examiner's comments with regard thereto, please enter the following amendments in the above-entitled application, without prejudice or disclaimer.